



Form PTO-1449

## INFORMATION DISCLOSURE STATEMENT

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| Attorney Docket: | P70853US0        |
| Application No.: | 10/554,048       |
| Filing Date:     | October 24, 2005 |
| Inventor:        | DOBSCHAL et al.  |
| Art Unit:        | Not Yet Assigned |
| Examiner:        | Not Yet Assigned |

## U.S. PATENT DOCUMENTS

| Examiner Initials* | Cite No. | Document Number     | Publication Date | Name of Patentee or Applicant | Relevant Pages, Cols, Lines, Figs. |
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| FP                 | AC       | US- 6,492,644       | 12/10/02         | STAIB                         |                                    |
| FP                 | AD       | US- 2003/0011896 A1 | 1/16/03          | SHIRAISHI                     |                                    |
| FP                 | AE       | US- 2001/0012099 A1 | 8/9/01           | KUMAGAI                       |                                    |
| FP                 | AF       | US- 2004/0174607 A1 | 9/9/04           | BRUNNER et al.                |                                    |
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## FOREIGN PATENT DOCUMENTS

| Examiner Initials* | Cite No. | Country Code + Number | Publication Date | Name of Patentee or Applicant | Relevant Pages, Cols, Lines, Figs. | Translation |
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| FP                 | AG       | DE 10130212 A1        | 1/2/03           | CARL ZEISS JENA GMBH          |                                    | SEE AF      |
| FP                 | AH       | EP 1 063 676 A        | 12/27/00         | STAIB INSTR GMBH              |                                    | SEE AC      |
| FP                 | AI       | DE 19929185 A1        | 6/25/99          | STAIB INSTR GMBH              |                                    | SEE AC      |
| FP                 | AJ       | DE 10063239 A1        | 12/19/00         | NIKON CORP                    |                                    | SEE AE      |
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## NON-PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. | Include name of author in CAPS; title of article; title of book, magazine, journal etc.; date; page(s); volume/issue number(s); publisher; city and/country where published.   |
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| FP                 | AK       | IMADA S ET AL; "Epitaxial Growth of Ferroelectric YMnO <sub>3</sub> thin films on Si (111) Substrates by Molecular Beam Epitaxy"; Japanese Journal of Applied Physics; Publication Office Japanese Journal of Applied Physics; December 1998; pgs. 6497-6501; vol. 37 no. 12A Part 1; Tokyo. |
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| Examiner Signature | /Fani Boosalis/ | Date Considered | 01/17/2007 |
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